

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hogan et al.

Art Unit: 3742

Serial No.: 10/635,824

Examiner: Van, Quang T.

Filed: 6 August 2003

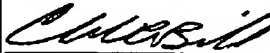
Docket No. TI-28996.1

For: METHOD FOR IMPROVING ASH RATE UNIFORMITY IN PHOTORESIST
ASHING PROCESS EQUIPMENT

AMENDMENT

22 October 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8 (a)	
I hereby certify that the above correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, PO Box 1450, Alexandria, Virginia, 22313-1450, or facsimile transmitted to the U.S. Patent and Trademark Office, on the date shown below.	
	22 Oct. 2004
Charles A. Brill	Date

Dear Sir:

In response to the Examiner's Action mailed 22 June 2004, applicant amends as follows: